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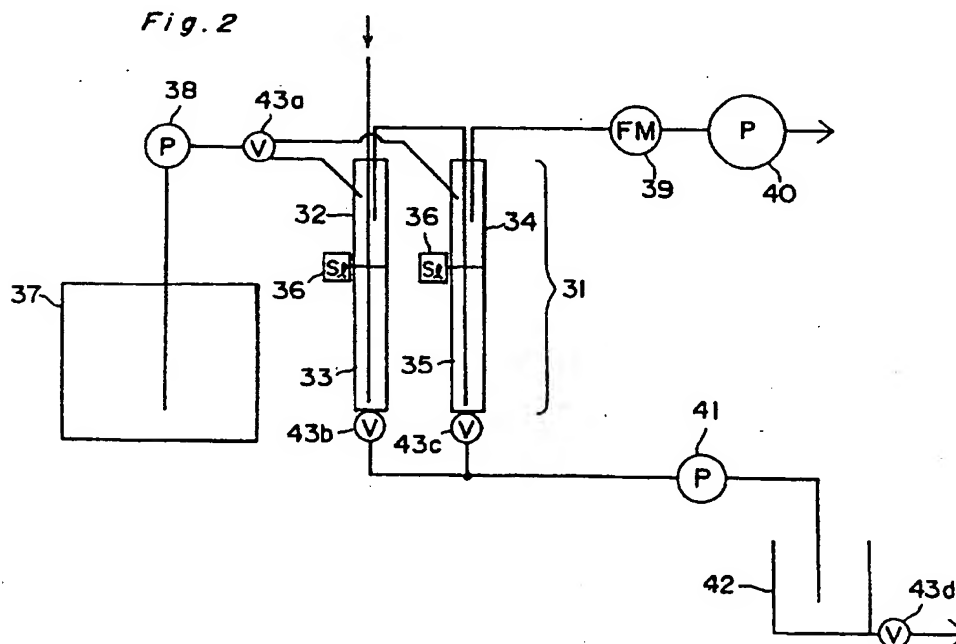
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(54) Collection and analysis of contaminants in an atmosphere

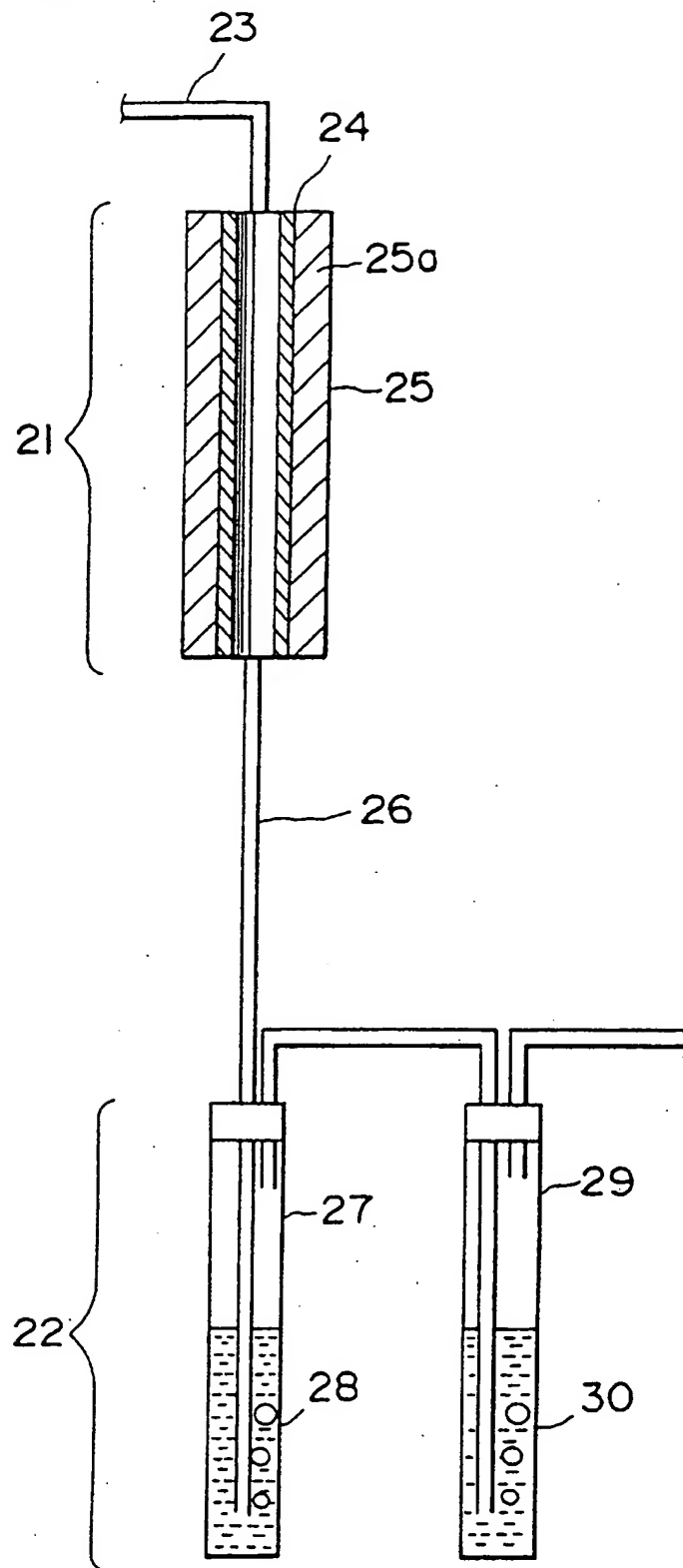
(57) A suction pump 40 draws an atmosphere sample into a two-stage impinger 32, 34 containing absorption liquid 33, 35, so that atmospheric impurities are collected in the liquids. A liquid transfer pump 41 transfers the absorption liquids 33, 35 to a measurement standby vessel 42, from which the liquids are transferred to an analysis apparatus for appropriate measurement. A liquid transfer pump 38 supplies new absorption liquid 33, 35 when the first and second stage impinger sections 32 and 34 are emptied. By thus repeatedly executing collection, transfer of liquid adsorbent and analysis, impurities in the atmosphere can be automatically obtained in real time.

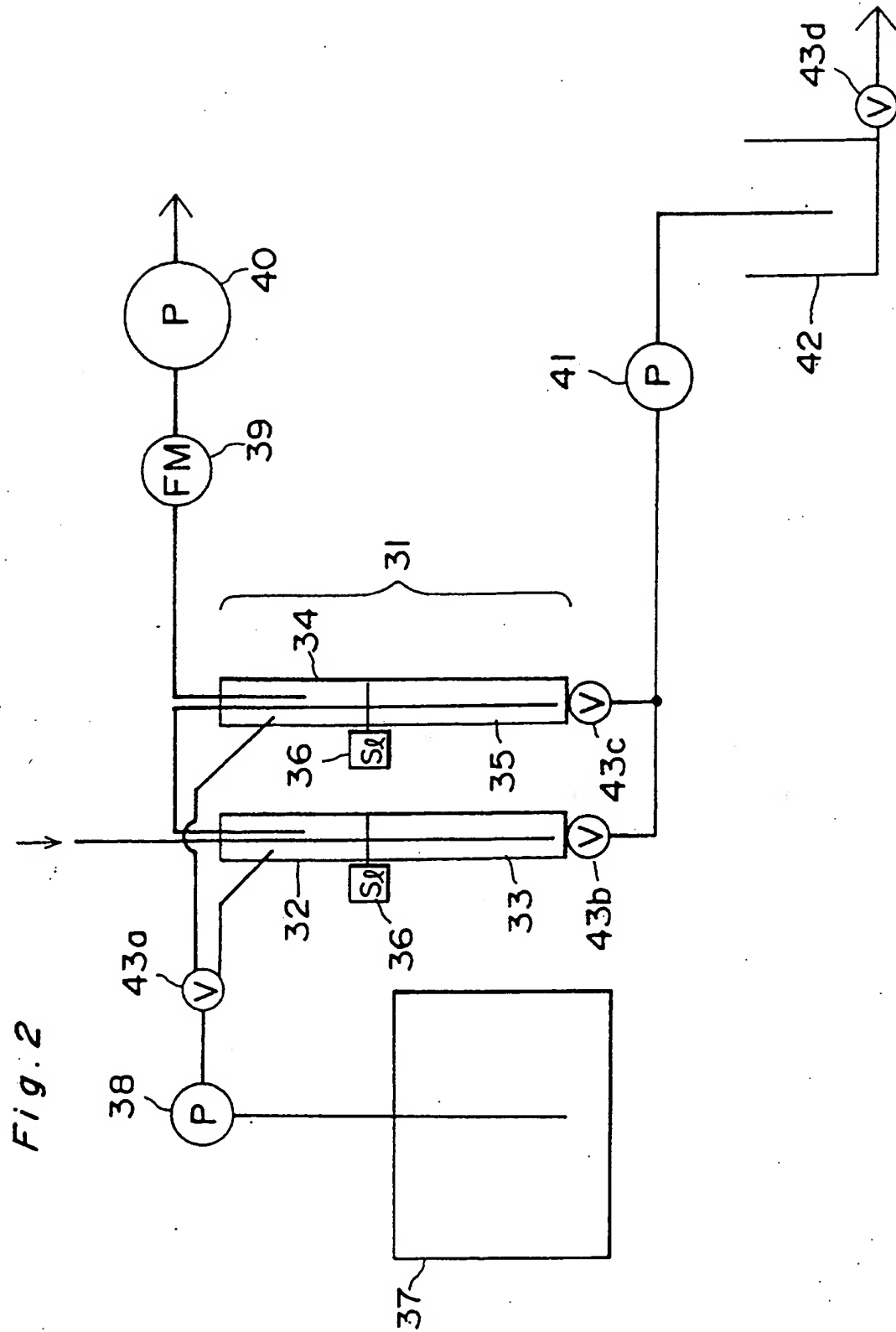


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Fig. 1





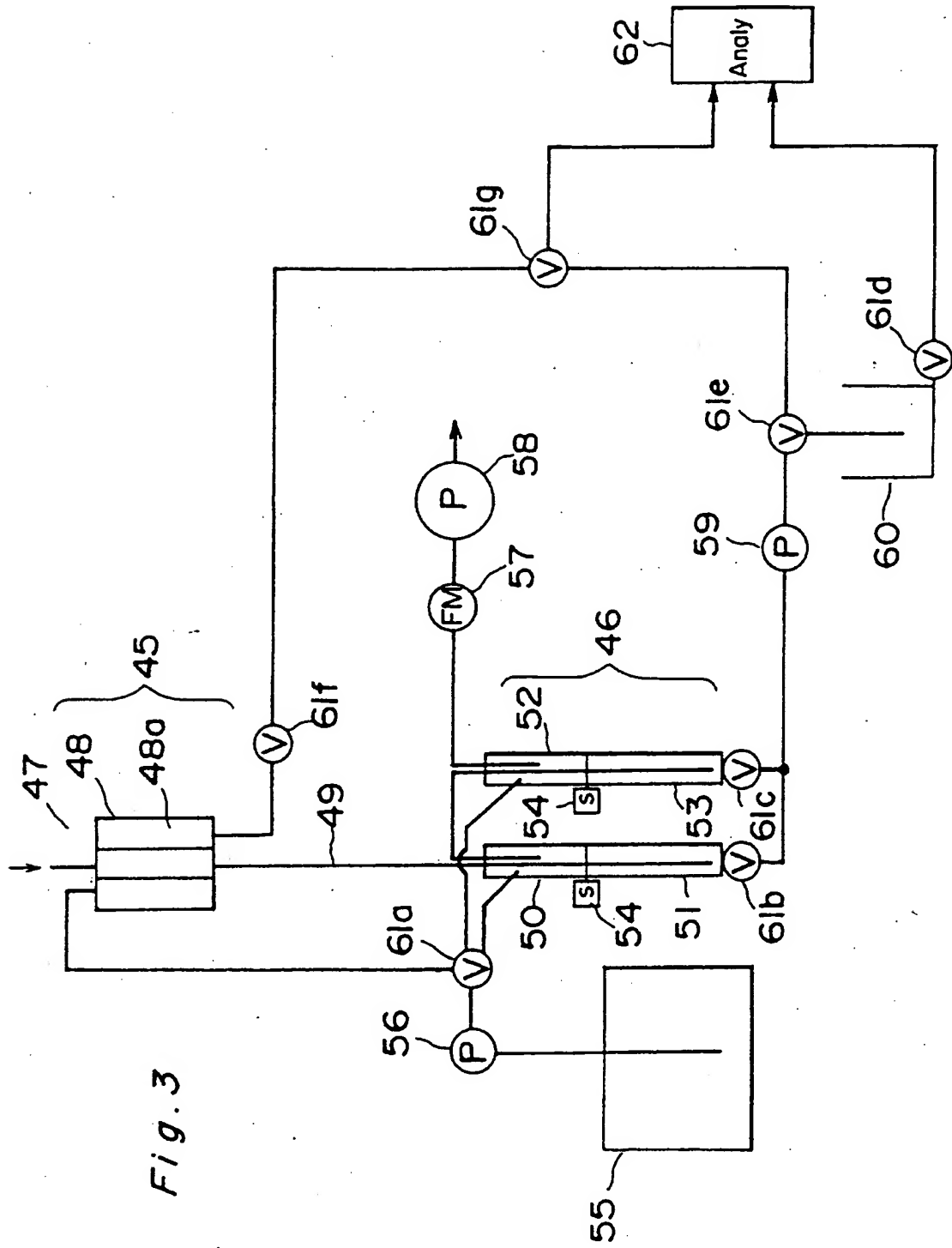
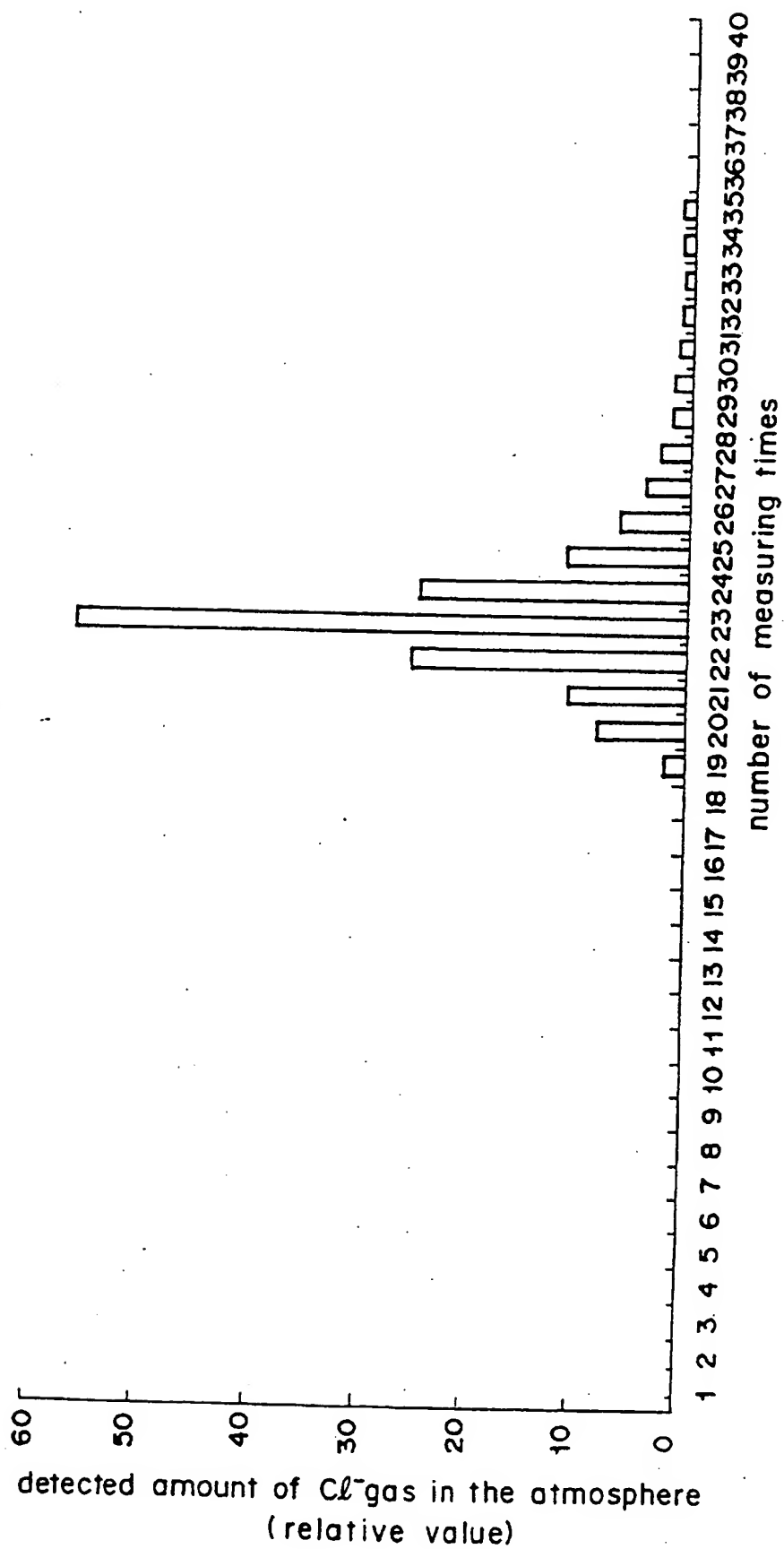
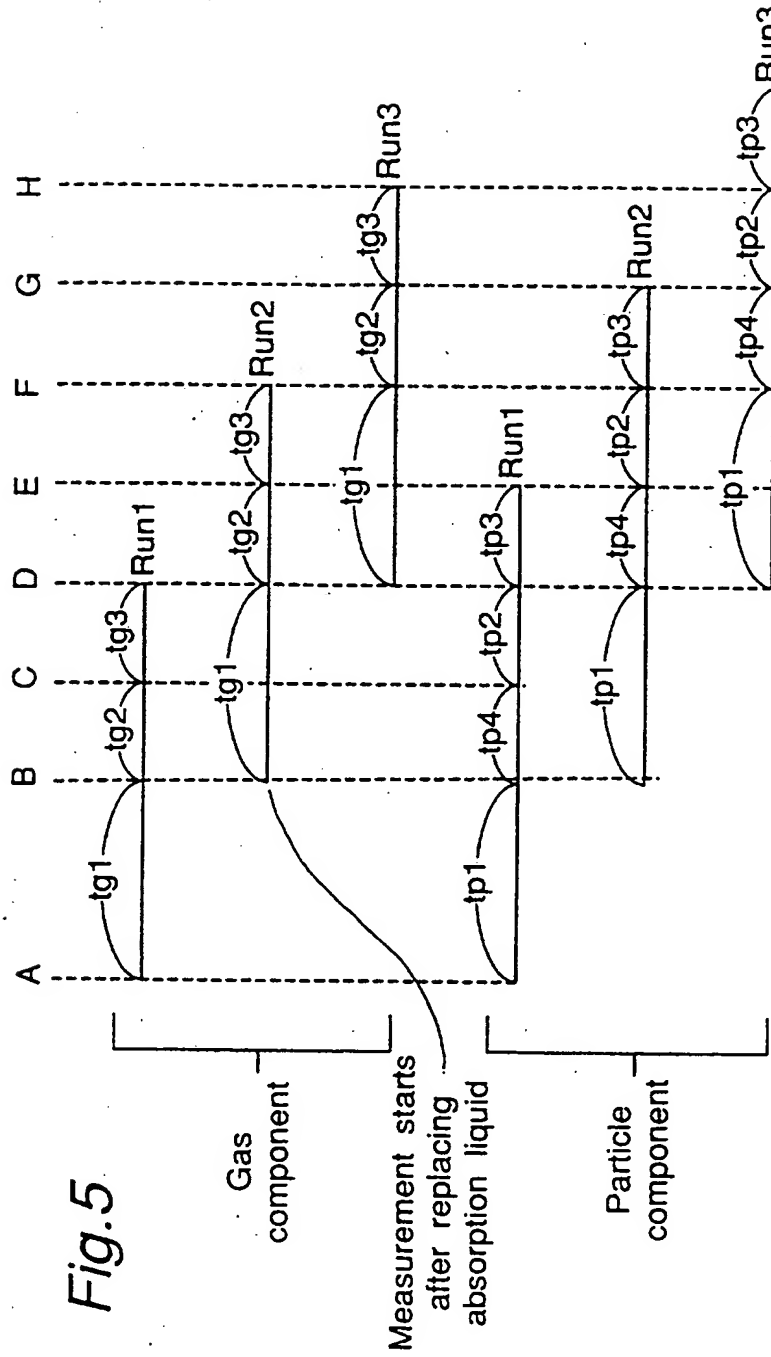


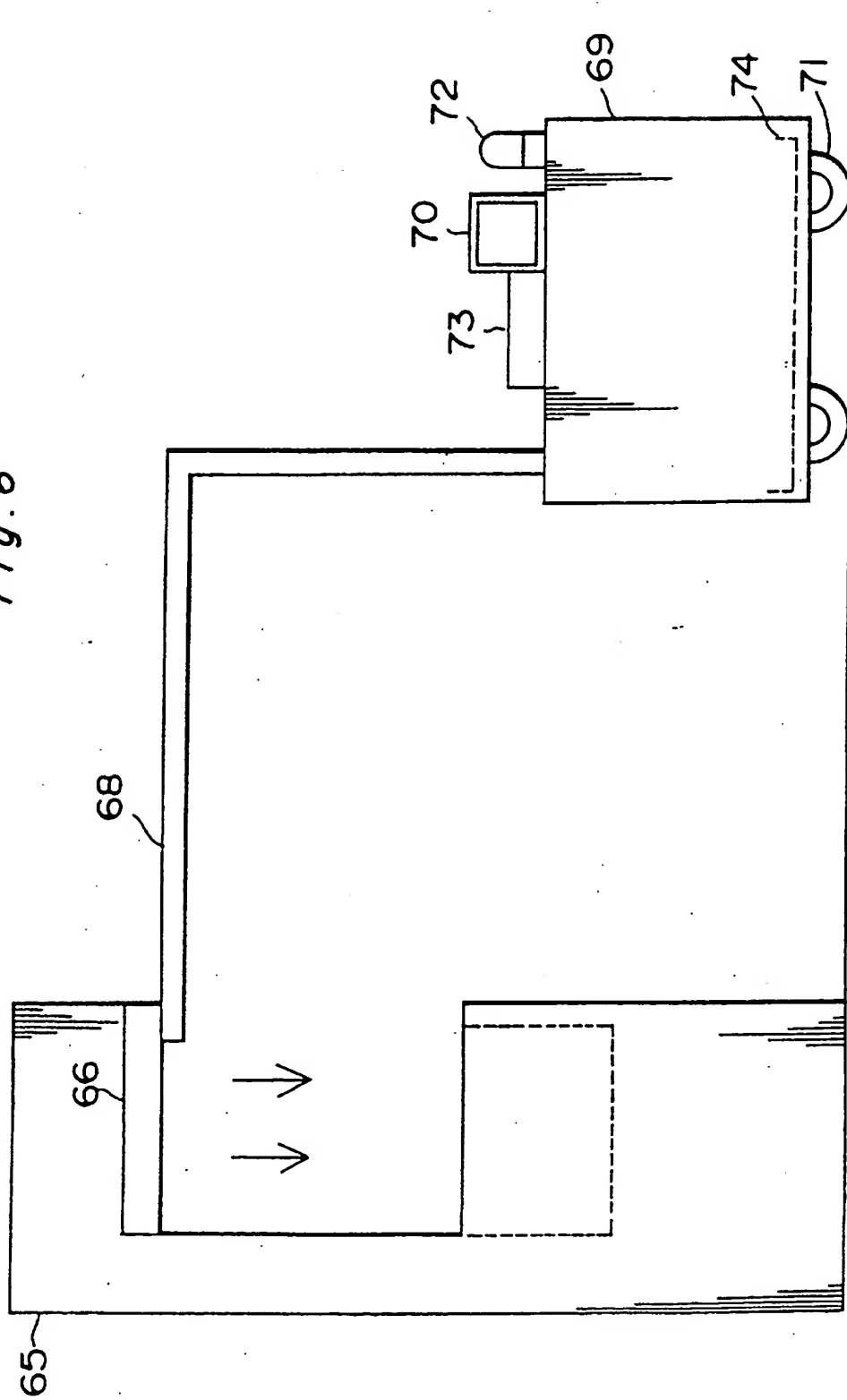
Fig. 4





- tg1, tp1 : Collecting (atmosphere sample suction) time (40 minutes at minimum)
 tg2, tp2 : Absorption liquid impurity condensing time (20 minutes at minimum, including cleaning)
 tg3, tp3 : Measurement time (20 minutes at minimum)
 tp4 : Measurement standby time (20 minutes at minimum)

Fig. 6



7/8

Fig. 7 PRIOR ART

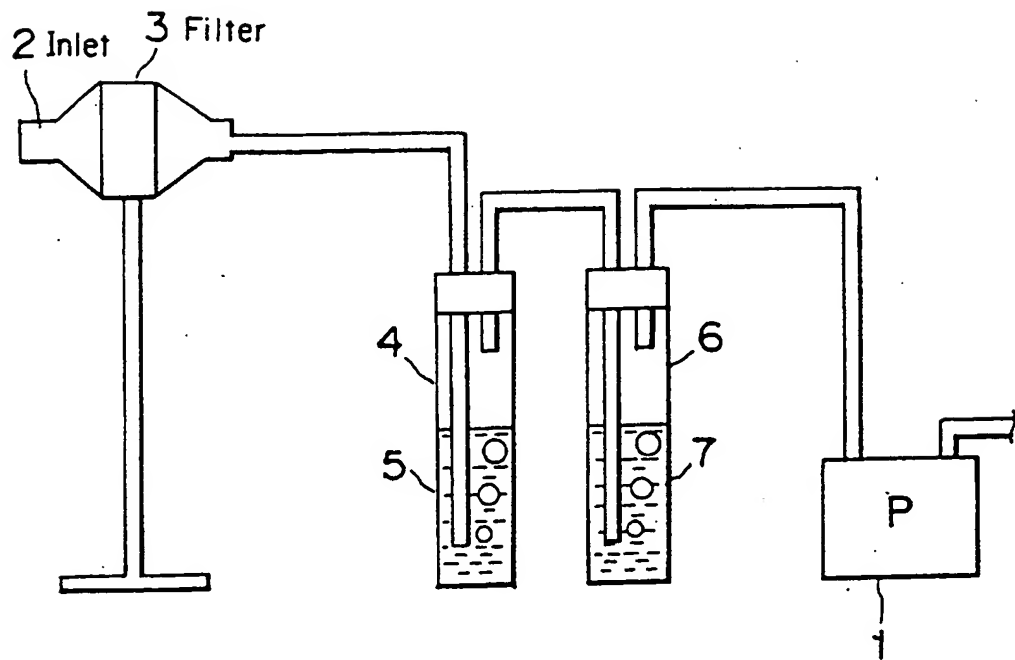


Fig. 8 PRIOR ART

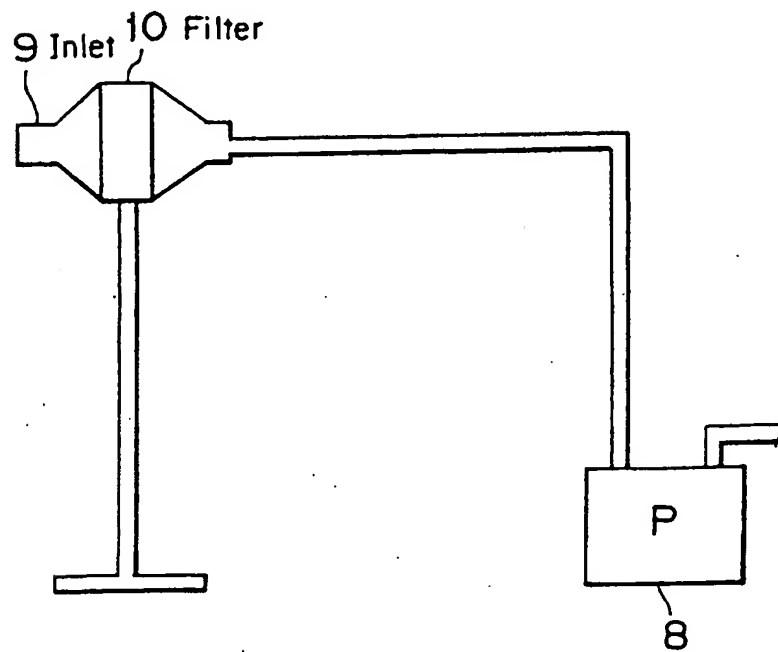


Fig.9 PRIOR ART

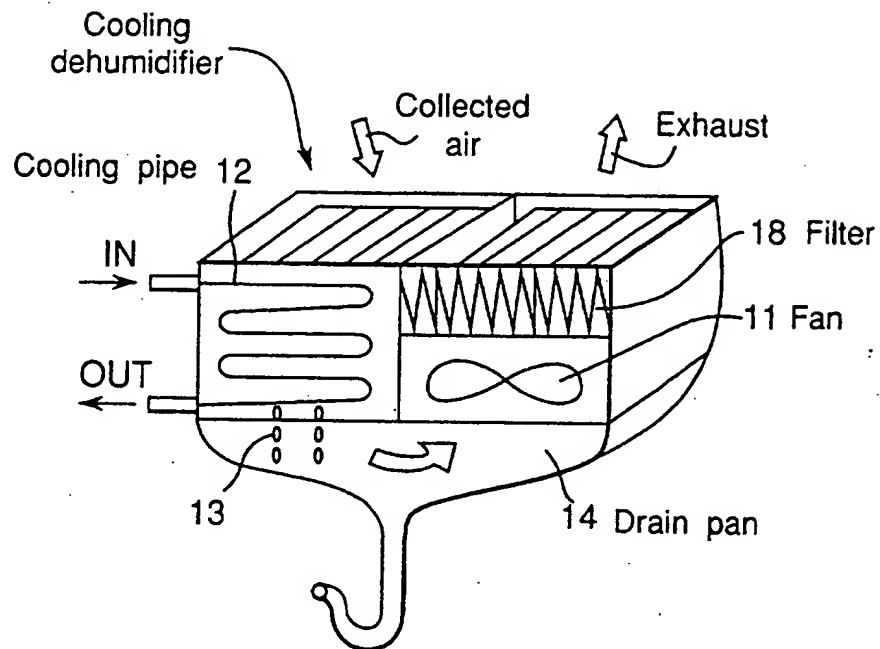
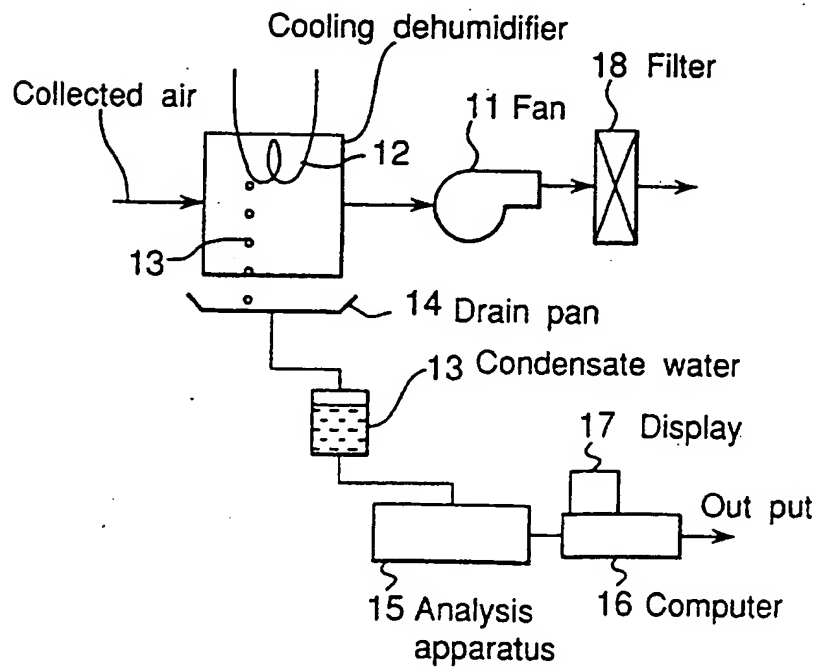


Fig.10 PRIOR ART



**APPARATUS FOR AUTOMATICALLY
ANALYSING IMPURITIES IN AN ATMOSPHERE**

BACKGROUND OF THE INVENTION

5

1. Field of the Invention

The present invention relates to an apparatus for analysing the impurities in an atmosphere, such as an atmosphere inside a clean room.

10

2. Description of the Prior Art

In a clean room of a semiconductor manufacturing plant, a variety of chemicals such as HF, H₂SO₄ and NH₄OH are used, and it is known that the gases generated from the chemicals exert various adverse effects. For example, HF resolves a glass fiber filter material of an HEPA (High-Efficiency Particulate Air) filter and generates B (Boron) contamination to affect the characteristics of semiconductors. Besides, NH₃ affects a chemically amplified resist for executing fine processing. Furthermore, when a plurality of these several kinds of gas components exist, the gas components grow into particles through chemical reactions to cause dust.

20

As a countermeasure against the atmospheric contamination, filters are generally used. It is to be noted that different filters are used for the removal of gas and particle. In the case of gas, a chemical filter
5 employing an activated carbon or an ion exchange resin is used, while the HEPA filter or the like is used in the case of particle.

Furthermore, in order to correctly ascertain the contaminant, it is important to correctly evaluate the
10 impurities in the atmosphere. For the above purpose, it is required to evaluate the impurities in the atmosphere in real time by state (gas, particle and so forth) and speedily feed the evaluation result back to an atmosphere control of the plant.

15 Conventionally, when collecting a gas component, the gas component has been collected by a method as shown in Fig. 7. According to this method, particles in the atmosphere which are taken in from an atmosphere sample intake 2 by the operation of an atmosphere sample suction
20 pump 1 are removed by a particle component collecting filter paper 3. Subsequently, the atmosphere is put through gas component collecting use absorption liquids 5 and 7 to be subjected to bubbling in a first stage impinger section 4 and a second stage impinger section 6, so that
25 the gas component is collected.

On the other hand, when collecting a particle component, as shown in Fig. 8, it is general to collect particles by passing an atmosphere which is taken in from an atmosphere sample intake 9 through a particle component
5 collecting filter paper 10 by the operation of an atmosphere sample suction pump 8.

There is another atmosphere analysis apparatus as shown in Figs. 9 and 10 (Japanese Patent Laid-Open Publication No. HEI 5-302872). This analysis apparatus
10 operates as follows to analyze the impurities in the atmosphere inside a clean room.

That is, a fan 11 is operated to guide the clean room atmosphere into a cooling dehumidifier having a cooling pipe 12 so as to condense its moisture into water
15 13. The condensate water 13 is received by a drain pan 14 and transferred to an analysis apparatus 15. Then, the impurities contained in the condensate water 13 are analyzed by the analysis apparatus 15 under the control of a computer 16, and the analysis result is displayed on a
20 display 17. It is to be noted that the air from which the moisture has been removed is put through a filter 18 to be discharged.

However, the gas component collecting method as shown in Fig. 7 has the following problem.

That is, when analyzing the collected gas component, the gas component collecting use absorption liquids 5 and 7 in both the impinger sections 4 and 6 are introduced into the analysis apparatus. However, since the
5 filter paper 3 is used for the removal of the particles, when the atmosphere contains particle components having a very high volatility (e.g., NH_4NO_3), the particle components are possibly gasified by the influence of the moisture of the atmosphere, so that the gasified particle components
10 will pass through the filter paper 3 to be mixed in the gas component. Therefore, an error may take place in the analysis result, causing an accuracy problem.

On the other hand, the particle component collecting method as shown in Fig. 8 has the following
15 problems.

That is, when analyzing the collected particle component, it is required to extract the particle component collected on the filter paper 10 by an acid solution and then introduce the solution into the analysis apparatus.
20 Therefore, when a particle component having a high volatility is contained, the particles will be gasified to possibly cause an error in the analysis result. Furthermore, there is such a problem that it is difficult to automate the analysis due to the increase of blank values

associated with a required extraction preprocessing by means of the filter paper and the inefficiency of the extracting process.

Accordingly, in order to monitor the impurities in the atmosphere inside the clean room using only the impingers, i.e. without using filter paper, it is required to collect the impurities in the atmosphere inside the clean room for a specified time using an apparatus obtained by removing the filter paper 3 from the structure shown in Fig. 7 and to execute analysis by collecting the collecting use absorption liquids 5 and 7. However, as of today, the analysis of the collecting use absorption liquids 5 and 7 has to be executed manually, resulting in reduced efficiency. Also, there is the problem of an error due to the possible occurrence of contamination during the manual work. Therefore, it is hard to achieve a quick, high-sensitivity measurement, and it is impossible to perform monitoring of the impurities in the atmosphere inside the clean room in real time. Also, there is such a problem that the impurities in the atmosphere cannot be analyzed by state.

Furthermore, the atmosphere analysis apparatuses as shown in Figs. 9 and 10 have such a problem that the impurities cannot be analyzed through discrimination between the states thereof (gas, particle and so forth). Furthermore, an impurity collecting section comprising the

cooling dehumidifier having the fan 11, cooling pipe
12, drain pan 14 and filter 18 cannot be cleaned.
Therefore, the contamination generated at each
analysis will accumulate to possibly cause a large
5 measurement error, resulting in the analysis result
being unreliable.

SUMMARY OF THE INVENTION

The present invention therefore aims to provide
an apparatus for automatically analysing the
10 impurities in the atmosphere in real time.

The present invention provides an apparatus for
the automatic analysis of impurities in an
atmosphere, comprising:

an impinger which is arranged to receive therein
15 an absorption liquid for impurities in an atmosphere;

a suction pump for sucking a gas inside the
impinger so as to draw the atmosphere into the
impinger and subject the atmosphere to bubbling in
the absorption liquid so that it collects the
20 impurities in the atmosphere;

a first liquid transfer pump for transferring
the absorption liquid containing the impurities from
the atmosphere to an analysis apparatus;

a second liquid transfer pump for supplying the
25 absorption liquid in an absorption liquid supply tank

to the impinger from which the absorption liquid containing the impurities from the atmosphere has been transferred; and

5 a control means for controlling operations of the suction pump, the first liquid transfer pump and the second liquid transfer pump to cause them to execute continuously repetitively the collection of the impurities in the atmosphere, the transfer of the absorption liquid to the analysis apparatus and the
10 supply of the absorption liquid to the impinger.

In the automatic analysis apparatus of the embodiment of the present invention, when the suction pump is driven to suck the gas in the impinger under the control of the control means, the atmosphere is
15 taken into the impinger to be subjected to bubbling in the absorption liquid, so that the impurities in the atmosphere are collected into the absorption liquid. Then, the first liquid transfer pump is driven to transfer the absorption liquid containing
20 the impurities to the analysis apparatus. Then, the second liquid transfer pump is driven to supply new absorption liquid to the emptied impinger.

Thus, the following processes are repetitively executed; collecting the impurities in the atmosphere
25 → transferring the absorption liquid to the analysis

apparatus → supplying new absorption liquid →
collecting the impurities in the atmosphere → ...,
so that the impurities in the atmosphere are
automatically analysed in real time.

5 BRIEF DESCRIPTION OF THE DRAWINGS

Embodiments of present invention will now be
described by way of example, with reference to the
accompanying drawings, in which:

10 Fig. 1 is a schematic view of an atmospheric
impurity collecting apparatus for implementing an
impurity collecting method, the apparatus and method
being in accordance with the invention claimed in
copending application 9617657.3, from which this
present application is divided;

15 Fig. 2 is a schematic view of an atmospheric
impurity automatic analysis apparatus in accordance
with the present invention;

20 Fig. 3 is a schematic view of an atmospheric
impurity state-by-state automatic analysis apparatus
also in accordance with the present invention;

Fig. 4 is a graph showing an example of real
time monitoring of a Cl^- gas component in the
atmosphere by the atmospheric impurity state-by-state
analysis apparatus shown in Fig. 3;

Fig. 5 is a view of a time table of the atmospheric impurity state-by-state automatic monitoring executed by the atmospheric impurity state-by-state analysis apparatus shown in Fig. 3;

5 Fig. 6 is an external view of an apparatus for monitoring impurities in the atmosphere in a clean room;

Fig. 7 is an explanatory view of a prior art gas component collecting method;

10 Fig. 8 is an explanatory view of a prior art particle component collecting method;

Fig. 9 is an external view of a cooling dehumidifier in a prior art atmosphere analysis apparatus; and

15 Fig. 10 is a general view of the atmosphere analysis apparatus including the cooling dehumidifier shown in Fig. 9.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

20 An atmospheric impurity collecting method will be described below with reference to Fig. 1.

The apparatus for collecting impurities in an atmosphere (hereinafter called "in-atmosphere impurities") is constituted broadly by a gas use absorption liquid vessel 25 having closed ends; a

tube 24 forming a cylindrical gas component permeable membrane which is made of porous polytetrafluoroethylene or the like and is disposed in the gas component collecting use absorption liquid vessel 25 with its opposite ends closely fitted to the respective ends of the gas component collecting use absorption liquid vessel 25; and a gas component collecting use absorption liquid 25a which is held inside the gas component collecting use absorption liquid vessel 25 and is in contact with an outer peripheral surface of the gas component permeable membrane tube 24. Both the opposite ends of the gas component collecting use absorption liquid vessel 25 are connected respectively to an atmosphere sample intake pipe 23 and a joint tube 26, both of which are in communication with the inside of the gas component permeable membrane tube 24.

On the other hand, the particle component collecting section 22 comprises: a first stage impinger section 27 which receives therein a first stage particle component collecting use absorption liquid 28; and a second stage impinger section 29 which receives therein a second stage particle component collecting use absorption liquid 30.

The in-atmosphere impurity collecting apparatus operates as follows.

First, an atmosphere sample taken in from the atmosphere sample intake pipe 23 passes through the inside of the gas component permeable membrane tube 24 of the gas component collecting section 21. At this stage, a gas component in the atmosphere sample is collected in the gas component collecting use absorption liquid 25a after permeating by diffusion through the gas component permeable membrane tube 24 in the radial direction. It is to be noted that pure water is used as the gas component collecting use absorption liquid 25a.

The atmosphere sample from which the gas component has been thus removed is conveyed through the joint tube 26 to the particle component collecting section 22. Then, after being subjected to bubbling in the first stage particle component collecting use absorption liquid 28 inside the first stage impinger section 27, the atmosphere sample is subjected to bubbling again in the second stage particle component collecting use absorption liquid 30 inside the second stage impinger section 29. Thus, the particle component in the atmosphere is collected in the

first stage particle component collecting use absorption liquid 28 and the second stage particle component collecting use absorption liquid 30.

5 It is to be noted that the first stage particle component collecting use absorption liquid 28 and the second stage particle component collecting use absorption liquid 30 are implemented by pure water in the case where an acid component and an ammonium component are analyzed, or by a dilute acid solution in the case where a metal
10 component is analyzed.

Furthermore, the two impinger sections of the first stage impinger section 27 and the second stage impinger section 29 are used for the purpose of collecting in the second stage impinger section 29 each particle
15 component which has not been able to be collected in the first stage impinger section 27.

As described above, according to the in-atmosphere impurity collecting method by means of the above in-atmosphere impurity collecting apparatus, by firstly
20 collecting the gas component into the gas component collecting use absorption liquid 25a and thereafter collecting the particle component into the first and second stage particle component collecting use absorption liquids 28 and 30, the impurities in the atmosphere can be

simultaneously collected while being separated into the gas component and the particle component.

Furthermore, since the impurities in the atmosphere are separated into the gas component and the particle component without using a filter paper, the impurities in the atmosphere can be surely separated into the gas component and the particle component even when a highly volatile particle component is included in the atmosphere.

Table 1 shows results of ICA (Ion Chromatometer)-evaluation of the impurities in the atmosphere inside the clean room collected by the above in-atmosphere impurity collecting apparatus.

Clean room atmosphere analysis results (relative values)

Collection place	F ⁻		Cl ⁻		NO ₂ ⁻		NO ₃ ⁻		SO ₄ ²⁻		NH ₄ ⁺	
	gas	particle	gas	particle	gas	particle	gas	particle	gas	particle	gas	particle
A	N.D	N.D	N.D	1.00	7.30	1.00	0.06	1.36	N.D	0.52	12.1	2.88
B	0.30	0.46	0.04	0.12	9.26	4.48	0.02	0.46	0.06	0.32	8.32	0.46
C	0.32	6.46	N.D	0.74	6.62	2.38	0.02	0.98	0.06	1.94	9.02	7.00
D	0.56	5.72	0.04	0.64	9.90	1.34	0.04	1.18	0.28	1.50	3.90	2.40
E	0.58	1.04	0.04	0.40	11.0	4.58	0.04	0.98	0.20	1.34	2.54	4.28

Note: N.D means no detection.

According to Table 1, a greater amount of NH_4^+ gas component is detected at the collection place A, indicating the need for a chemical filter for removing the gas component and specifying the NH_4^+ gas component as
5 the contamination source.

Furthermore, the collection places B and C are in the vicinity of the same processing apparatus in the clean room, and it can be found that particle components of most impurities are detected in greater concentration
10 at the rear side, or utility area of the apparatus (collection place C) than at the front side, or the processing area of the apparatus (collection place B). These analysis results conform to the difference in cleanness between the processing area and the utility
15 area inside the clean room, and prove the effectiveness of the collecting method performed by the above in-atmosphere impurity collecting apparatus. It is to be noted that F⁻ gas component is detected in the collection place B, and this indicates that steps need to be taken
20 to avoid B (Boron) contamination due to the glass fiber filter material of the HEPA filter.

Furthermore, the collection places D and E are places where the collecting is executed for the purpose of evaluating a chemical filter, by comparing the results
25 from the IN side (collection place D) and the OUT side (collection place E) of a ammonium removing chemical filter. According to

According to Table 1, a greater amount of NH_4^+ gas component is detected at the collection place A, indicating the need for a chemical filter for removing the gas component and specifying the NH_4^+ gas component as the contamination source.

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Furthermore, the collection places D and E are places where the collecting is executed for the purpose of evaluating a chemical filter, by comparing the results from the IN side (collection place D) and the OUT side (collection place E) of a ammonium removing chemical filter. According to

this comparison, the NH_4^+ gas component on the OUT side is reduced only by about 30 percent compared with that on the IN side of the chemical filter. Judging from the fact that this chemical filter has a capacity of removing not less than 90 percent of the NH_4^+ gas component, it can be determined that the chemical filter is exhausted and needs to be replaced.

By thus using the above in-atmosphere impurity collecting method, the amount of the impurities in the atmosphere can be evaluated by state (gas and particle). Therefore, an appropriate countermeasure against the impurities in the atmosphere can be taken, and the method is thus very effective.

An in-atmosphere impurity automatic analysis apparatus capable of automatically analyzing impurities in the atmosphere by means of an impinger will be described next with reference to Fig. 2.

In this in-atmosphere impurity automatic analysis apparatus, an atmosphere sample suction pump 40 sucks the gas inside a first and a second stage impinger sections 32, 34 of an impinger section 31 having the same construction as that of the particle component collecting section 22 shown in Fig. 1, a collecting use absorption liquid transfer pump 41 introduces collecting use absorption liquids 33 and 35 for both the impinger sections 32 and 34

into a measurement standby vessel 42 and an absorption liquid supply use liquid transfer pump 38 supplies a collecting use absorption liquid in an absorption liquid supply tank 37 to both the impinger sections 32 and 34.

5 The in-atmosphere impurity automatic analysis apparatus constructed as above operates as follows to automatically monitor the impurities in the atmosphere in real time.

10 That is, when the gases inside the first and the second stage impinger sections 32, 34 are sucked via a flow meter 39 by the atmosphere sample suction pump 40, an atmosphere sample is taken into the impinger section 31 at a constant flow rate. The atmosphere sample thus taken in is subjected to bubbling in the first stage impinger section 32, so that the impurities are collected into the first stage collecting use absorption liquid 33. Then, each impurity which has not been collected in the first stage impinger section 32 is subsequently subjected to bubbling again in the second stage impinger section 34, so that each impurity is collected into the second stage collecting use absorption liquid 35.

20 It is to be noted that the first and the second stage collecting use absorption liquids 33, 35 are supplied from the absorption liquid supply tank 37 via a liquid transfer on-off valve 43a by the absorption liquid supply

25

use liquid transfer pump 38, while the liquid supply amount is adjusted to a specified amount by a liquid surface sensor 36.

When the atmosphere sample is sucked in
5 for a specified time to complete the collecting operation, the liquid amounts of the collecting use absorption liquids 33 and 35 in the impinger sections 32 and 34 become reduced. Therefore, by the operation of the absorption liquid supply use transfer pump 38 and
10 liquid surface sensors 36, the collecting use absorption liquids 33 and 35 are each restored to a specified amount (i.e., to the liquid amount prior to the start of the collecting operation). Thereafter, the collecting use absorption liquids 33 and 35 are introduced into the measurement
15 standby vessel 42 by the collecting use absorption liquid transfer pump 41, so that the collecting use absorption liquids 33 and 35 are mixed with each other. Then, a liquid transfer on-off valve 43d is opened to transfer the collecting use absorption liquid in the measurement standby
20 vessel 42 to an analysis apparatus (not shown) such as a two-way simultaneous measurement ion chromato-analyzer based on, for example, a condensed column method to execute analysis.

By thus providing the measurement standby vessel
25 42, the collecting use absorption liquids 33 and 35 in the

respective two impinger sections 32 and 34 can be analysed simultaneously.

Further, by using the analysis apparatus based on the condensed column method as the analysis apparatus, a
5 correct analysis can be achieved even when the amount of the collected impurities is small due to a short collecting time.

By repeating the above operations, real time monitoring of the impurities in the atmosphere is performed
10 automatically.

In the above case, the liquid transfer on-off valves 43b and 43c are opened to transfer both the collecting use absorption liquids 33 and 35 to the measurement standby vessel 42, and then the liquid transfer
15 on-off valve 43a is opened to supply new collecting use absorption liquid to both the impinger sections 32 and 34. Therefore, the collecting use absorption liquids 33 and 35 inside the respective first and second stage impinger sections 32, 34 are replaced for every analysis of
20 impurities, so that the first stage impinger section 32 and the second stage impinger section 34 are internally cleaned. That is, the present in-atmosphere impurity automatic analysis apparatus has a cleaning function, and the cleaning function can be obtained in accordance with

the timing of opening and closing the liquid transfer on-off valves 43a through 43c at each time of collecting.

As described above, the in-atmosphere impurity automatic analysis apparatus of the present embodiment is provided with impingers, and the atmosphere sample suction pump 40 is driven to draw the atmosphere sample by suction into the first and second stage impinger sections 32 and 34 so as to collect the impurities into both the collecting use absorption liquids 33 and 35. Then, by driving the collecting use absorption liquid transfer pump 41, both the collecting use absorption liquids 33 and 35 are introduced into the measurement standby vessel 42 to be mixed with each other, and then transferred to the analysis apparatus to be condensed and analysed.

Therefore, according to the present in-atmosphere impurity automatic analysis apparatus, the collecting and measurement of the impurities can be automatically executed to allow automatic monitoring of the impurities in the atmosphere to be achieved.

Furthermore, the collecting use absorption liquids 33 and 35 inside the respective first and the second stage impinger sections 32, 34 are replaced in accordance with the timing of opening and closing the liquid transfer on-off valves 43a through 43c at each time of collecting, so that both the impinger sections 32 and 34

are cleaned. That is, the present in-atmosphere impurity automatic analysis apparatus has a cleaning function.

It is to be noted that each of the first and second stage impinger sections 32 and 34 of the present embodiment is more elongated than the prior art impinger so as to reduce the required amount of the collecting use absorption liquids 33 and 35 and to assure an increased time of contact between the bubbles generated by the bubbling and the collecting use absorption liquids 33 and 35.

An in-atmosphere impurity state-by-state analysis apparatus which is provided with the in-atmosphere impurity collecting apparatus shown in Fig. 1 and is capable of automatically analyzing the impurities in the atmosphere by state will be described next with reference to Fig. 3.

This in-atmosphere impurity state-by-state analysis apparatus has a general construction such that a joint tube 49 of the gas component collecting section 45, which is the same construction as that of the gas component collecting section 21 in the in-atmosphere impurity collecting apparatus shown in Fig. 1, is connected to the atmosphere sample intake of an analysis apparatus, which is the same construction as that of the in-atmosphere impurity automatic analysis apparatus shown in Fig. 2. An upper portion of the gas component collecting use absorption

liquid vessel 48 of the gas component collecting section 45 is connected with a liquid transfer on-off valve 61a of the above analysis apparatus via a liquid transfer pipe, while a bottom portion of the gas component collecting use absorption liquid vessel 48 of the gas component collecting section 45 is connected with the downstream side of the particle component collecting use liquid transfer pump 59 of the above analysis apparatus via a bifurcated liquid transfer pipe provided with interposition of liquid transfer on-off valves 61e through 61g.

This in-atmosphere impurity state-by-state analysis apparatus operates as follows to execute automatic state-by-state monitoring of the impurities in the atmosphere in real time.

First, the atmosphere sample suction pump 58 is driven to take in an atmosphere sample at a specified flow rate into a gas component permeable membrane tube 47 of the gas component collecting section 45. As the atmosphere sample passes through the gas component collecting section 45, only the gas component of the atmosphere sample is taken out of the gas component permeable membrane tube 47 and then collected into the gas component collecting use absorption liquid 48a. Then the atmosphere sample being rid of only the gas component is introduced into a particle component collecting section 46 via the joint tube 49.

The atmosphere being rid of the gas component is subjected to bubbling in a first stage impinger section 50 of the particle component collecting section 46, so that the particle component is collected into a first stage particle component collecting use absorption liquid 51. Further, each particle component which has not been collected in the first stage impinger section 50 is subjected to bubbling again in a second stage impinger section 52 to be collected into a second stage particle component collecting use absorption liquid 53.

It is to be noted that the gas component collecting use absorption liquid 48a and both the particle component collecting use absorption liquids 51 and 53 are supplied from an absorption liquid supply tank 55 via the liquid transfer on-off valve 61a by a specified amount at each time of measurement by the absorption liquid supply use liquid transfer pump 56.

As described above, when the atmosphere sample is drawn in by suction for a specified time to complete the collecting of the components, firstly the gas component collecting use absorption liquid 48a is introduced into an analysis apparatus 62 such as a two-way simultaneous measurement ion chromat analyzer based on, for example, a condensed column method upon opening the liquid transfer

on-off valves 61f and 61g, and then subjected to measurement after being condensed.

On the other hand, both the particle component collecting use absorption liquids 51 and 53 are temporarily introduced into a particle component measurement standby vessel 60 to wait for the measurement time by the particle component collecting use liquid transfer pump 59 upon opening the liquid transfer on-off valves 61b, 61c and 61e. Then, after the above mentioned measurement of the gas component collecting use absorption liquid 48a is completed, the absorption liquid in the vessel 60 is introduced into the analysis apparatus 62 to be condensed and measured.

By repeating the above operations, the state-by-state automatic monitoring of the impurities as both gas and particle components in the atmosphere is performed in real time.

Fig. 4 shows an example of the real time monitoring of a Cl^- gas component in the atmosphere.

In Fig. 4, the amount of the Cl^- gas component in the atmosphere increases at and around the 23th time of measurement, and this indicates the occurrence of a certain contamination. Therefore, it can be presumed that the apparatus processed at the 23th time of measurement is the source of contamination.

The above implies that the present in-atmosphere impurity state-by-state analysis apparatus is very effective in ascertaining the contamination source in real time.

5 The present in-atmosphere impurity state-by-state analysis apparatus operates according to a time table as shown in Fig. 5 to perform the state-by-state automatic monitoring of the impurities in the atmosphere under the control of a computer or the like.

10 The time table in Fig. 5 shows the first time (Run 1) through the third time (Run 3) of the collecting, standby, condensation and measurement by the gas component and the particle component, and this time table will be repeated in the fourth and subsequent times.

15 It is to be noted that the symbols in Fig. 5 indicate the following items.

Time table of gas component:

tg1: Collecting by means of the gas component collecting section 45

20 tg2: Condensation of the gas component collecting use absorption liquid 48a by the analysis apparatus 62

tg3: Measurement by the analysis apparatus

62

25 Time table of particle component:

tp1: Collecting by means of the particle
component collecting section 46

tp2: Condensation of the particle component
collecting use absorption liquids 51
and 53 by the analysis apparatus 62

tp3: Measurement by the analysis apparatus
62

tp4: Standby for measurement

At the time point A in the above time table, the
first time collecting (tg1-1) of the gas component and the
first time collecting (tp1-1) of the particle component are
started simultaneously.

At a time point B, the first time condensation
(tg2-1) of the gas component collecting use absorption
liquid 48a and the first time transfer (tp4-1) of the
particle component collecting use absorption liquids 51 and
53 to the particle component measurement standby vessel 60
are executed simultaneously. At the same time, new
absorption liquid is supplied to the emptied gas component
collecting use absorption liquid vessel 48 and to the first
and second stage impinger sections 50 and 52, and then the
second time collecting (tg1-2) of the gas component and the
second time collecting (tp1-2) of the particle component
are also started.

At a time point C, the first time measurement (tg3-1) of the gas component collecting use absorption liquid 48a and the first time condensation (tp2-1) of the particle component collecting use absorption liquids 51 and 53 are executed simultaneously.

At a time point D, the first time measurement (tp3-1) of the particle component collecting use absorption liquids 51 and 53 is executed. At the same time, the second time condensation (tg2-2) of the gas component collecting use absorption liquid 48a and the second time transfer (tp4-2) of the particle component collecting use absorption liquids 51 and 53 to the particle component measurement standby vessel 60 are also executed. Simultaneously, the third time collecting (tg1-3) of the gas component and the third time collecting (tp1-3) of the particle component are also started.

Thus, the first time collecting and measurement of the impurities in the atmosphere is executed at the time point A through the time point E.

At the time point E, the second time measurement (tg3-2) of the gas component collecting use absorption liquid 48a and the second time condensation (tp2-2) of the particle component collecting use absorption liquids 51 and 53 are executed simultaneously.

At a time point F, the second time measurement (tp3-2) of the particle component collecting use absorption liquids 51 and 53 is executed. At the same time, the third time condensation (tg2-3) of the gas component collecting use absorption liquid 48a and the third time transfer (tp4-3) of the particle component collecting use absorption liquids 51 and 53 to the particle component measurement standby vessel 60 are executed.

Thus, the second time collecting and measurement of the impurities in the atmosphere is executed at the time point B through the time point G.

At the time point G, the third time measurement (tg3-3) of the gas component collecting use absorption liquid 48a and the third time condensation (tp2-3) of the particle component collecting use absorption liquids 51 and 53 are executed simultaneously.

At a time point H, the third time measurement (tp3-3) of the particle component collecting use absorption liquids 51 and 53 is executed.

Thus, the third time collecting and measurement of the impurities in the atmosphere that has been started at the time point D is completed.

That is, according to the above time table, by executing the collecting of the atmosphere for the gas component or the particle component in 40 minutes at

minimum and executing the other operations of condensation, measurement and standby in 20 minutes at minimum, the operation sequence from the collecting of the atmosphere for the gas component or the particle component to the
5 condensation and measurement of the components can be executed in parallel while shifting the timing by 40 minutes at minimum.

As a result, the collecting of the atmosphere is executed every 40 minutes, so that the measurement result
10 of the gas component is obtained after the elapse of 40 minutes from the completion of the collecting, and the measurement result of the particle component is obtained after the elapse of 60 minutes from the completion of the collecting.

15 It is to be noted that, after the gas component collecting use absorption liquid 48a and the particle component collecting use absorption liquids 51 and 53 are transferred to the analysis apparatus 62 or the particle component measurement standby vessel 60 by operating the
20 liquid transfer on-off valves 61f and 61g, operating the liquid transfer on-off valves 61b, 61c and 61e and driving the particle component collecting use liquid transfer pump 59, the gas component collecting use absorption liquid 48a and the particle component collecting use absorption
25 liquids 51 and 53 are supplied by operating the liquid

transfer on-off valve 61a and driving the absorption liquid supply use liquid transfer pump 56. Thus, replacement of the absorption liquids inside the gas component collecting use absorption liquid vessel 48 and the first and second stage impinger sections 50 and 52 are executed.

In this case, a time required for the replacement of the absorption liquids is several tens of seconds. Therefore, taking into account the fact that the minimum measurement time is 40 minutes as described above, it can be said that a loss time required for the replacement of the absorption liquids does not exert a great influence on the measurement results.

Furthermore, as described above, the collecting use absorption liquids 48a, 51 and 53 in the gas component collecting use absorption liquid vessel 48, the first stage impinger section 50 and the second stage impinger section 52 are replaced in accordance with the timing of opening and closing the liquid transfer on-off valves 61a through 61g in each time of measurement, so that the gas component collecting use absorption liquid vessel 48 and both the impinger sections 50 and 52 are cleaned. That is, the present in-atmosphere impurity state-by-state analysis apparatus has a cleaning function.

Thus, according to the present in-atmosphere impurity state-by-state analysis apparatus, which has the

in-atmosphere impurity collecting apparatus shown in Fig. 1, first the gas component in the atmosphere sample is collected into the gas component collecting use absorption liquid 48a by drawing the atmosphere sample into the gas component collecting section 45 by means of the atmosphere sample suction pump 58, secondly the particle component is collected into the particle component collecting use absorption liquids 51 and 53 in the particle component collecting section 46.

Then, the particle component collecting use absorption liquids 51 and 53 are made to stand by in the particle component measurement standby vessel 60 by driving the particle component collecting use liquid transfer pump 59, while the gas component collecting use absorption liquid 48a is transferred to the analysis apparatus 62 to be condensed and measured. Then new absorption liquid is supplied to the thus emptied gas component collecting use absorption liquid vessel 48 and the first and second stage impinger sections 50 and 52 by driving the absorption liquid supply use liquid transfer pump 56, and the next atmosphere sample is started to be drawn in by suction.

When the measurement of the gas component collecting use absorption liquid 48a is completed in the meantime, the particle component collecting use absorption liquids 51 and 53 that are standing by in the particle

component measurement standby vessel 60 are transferred to the analysis apparatus 62 to be condensed and measured.

Therefore, according to the present in-atmosphere impurity state-by-state analysis apparatus, the collecting, condensation and measurement can be executed in parallel by the gas component and the particle component with a timing shift according to the time table shown in Fig. 5, thereby allowing the state-by-state automatic monitoring of the impurities in the atmosphere to be repetitively performed in real time.

It is generally said that the in-atmosphere impurity collecting method by means of an impinger requires a long collecting time (atmosphere sample suction time) due to its degraded sensitivity. However, each of the first and second stage impinger sections 50 and 52 of the present in-atmosphere impurity state-by-state analysis apparatus has a shape elongated more than that of the prior art impinger for the purpose of assuring a longer time of contact of the atmosphere with the particle component collecting use absorption liquids 51 and 53. Therefore, it is not required to extend the collecting time.

Furthermore, by using the analysis apparatus based on the condensed column method as the analysis apparatus 62, a small amount of impurities can be measured even in a short collecting time.

It is to be noted that the contents of the absorption liquids 48a, 51 and 53 are not limited to those of the present embodiment. Furthermore, different analysis apparatuses 62 may be used for the gas component and the
5 particle component.

For example, when measuring metal impurities such as Fe, Cr, Ni and the like other than the acid component and the ammonium component in the above in-atmosphere impurity state-by-state analysis apparatus, it is proper to
10 use a diluted acid solution for the particle component collecting use absorption liquids 51 and 53 and measure the particle component collecting use absorption liquids 51 and 53 that have been introduced into the particle component measurement standby vessel 60 by introducing them into an
15 ICP-AES (Inductively Coupled Plasma-Atomic Emission Spectrometer), an ICP-MS (Inductively Coupled Plasma-Mass Spectrometer) or an FL-AAS (Flameless Atomic Absorption Spectrometer) and the like.

A clean room in-atmosphere impurity monitoring
20 apparatus employing the in-atmosphere impurity state-by-state analysis apparatus shown in Fig. 3 will be described next.

Fig. 6 is a schematic view of the clean room in-atmosphere impurity monitoring apparatus.

This clean room in-atmosphere impurity monitoring apparatus is used for correctly determining the time for replacement of an HEPA filter unit 66 mounted to a production processing apparatus 65.

5 In its main body 69 is stored an in-atmosphere impurity state-by-state analysis apparatus (not shown) identical to the in-atmosphere impurity state-by-state analysis apparatus shown in Fig. 3. Then, the operations of the atmosphere sample suction pump, the absorption
10 liquid supply use liquid transfer pump, the particle component collecting use absorption liquid transfer pump, and the liquid transfer on-off valves of this in-atmosphere impurity state-by-state analysis apparatus are executed by a control computer 73 according to the time table shown in
15 Fig. 5, so that the monitoring of the impurities in the atmosphere inside the clean room is executed continuously automatically.

The present clean room in-atmosphere impurity monitoring apparatus is further provided with a display 70
20 for displaying the analysis results of the impurities and a contamination occurrence warning lamp 72 for issuing warning of the occurrence of atmospheric contamination according to the above analysis results.

The clean room in-atmosphere impurity monitoring apparatus constructed as above operates as follows under the control of the control computer 73.

5 The atmosphere that has been put through the HEPA filter unit 66 of the production processing apparatus 65 is drawn by suction into the in-atmosphere impurity state-by-state analysis apparatus inside the main body 69 from an atmosphere sample intake pipe 68. Then, the impurities in the atmosphere are analyzed by state according to the time
10 table shown in Fig. 5, and the analysis results are displayed on the display 70 so as to consistently confirm the states of the impurities in the atmosphere. Further, when the density of any impurity exceeds the reference value thereof registered in a memory of the control
15 computer 73, the contamination occurrence warning lamp 72 is lit to inform the operators in surrounding areas of the time of replacement of the HEPA filter unit 66.

It is to be noted that the floor inside the clean room is normally a grating, and therefore, a significant
20 unevenness is there. By increasing the diameter of the moving wheels 71, they can easily be made to roll over the unevenness of the floor.

Furthermore, in case of possible accidental leakage of the impurity collecting use absorption liquid or
25 the like, a function of automatically stopping

the collecting and analysis as well as a liquid leak preventing tray 74 which receives the leaked absorption liquid or the like are provided.

5 In the above clean room in-atmosphere impurity monitoring apparatus, the in-atmosphere impurity state-by-state analysis apparatus identical to the in-atmosphere impurity state-by-state analysis apparatus shown in Fig. 3 is stored in the main body 69. However, if the state-by-state analysis is not specifically required, an in-
10 atmosphere impurity automatic analysis apparatus identical to the in-atmosphere impurity automatic analysis apparatus shown in Fig. 2 may be stored therein.

CLAIMS:

1. An apparatus for the automatic analysis of impurities in an atmosphere, comprising:
 - 5 an impinger which is arranged to receive therein an absorption liquid for impurities in an atmosphere;
a suction pump for sucking a gas inside the impinger so as to draw the atmosphere into the impinger and subject the atmosphere to bubbling in the absorption liquid so
10 that it collects the impurities in the atmosphere;
a first liquid transfer pump for transferring the absorption liquid containing the impurities from the atmosphere to an analysis apparatus;
a second liquid transfer pump for supplying the
15 absorption liquid in an absorption liquid supply tank to the impinger from which the absorption liquid containing the impurities from the atmosphere has been transferred;
and
a control means for controlling operations of the
20 suction pump, the first liquid transfer pump and the second liquid transfer pump to cause them to execute continuously repetitively the collection of the impurities in the atmosphere, the transfer of the absorption liquid to the analysis apparatus and the supply of the absorption
25 liquid to the impinger.

2. An apparatus for the automatic analysis of impurities in an atmosphere, substantially as hereinbefore described with reference to Figure 2 of the accompanying drawings.

5 3. A clean room in-atmosphere impurity monitoring apparatus substantially as hereinbefore described with reference to Figure 6 of the accompanying drawings, including an automatic analysis apparatus according to claim 1 or claim 2.



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Claims searched: All

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Databases searched:

UK Patent Office collections, including GB, EP, WO & US patent specifications, in:

UK Cl (Ed.P): G1B (BCE, BCF, BCH); B1T (TPJX, TPLA, TPPD)

Int Cl (Ed.6): G01N 1/22, 1/24, 33/00; B01D 47/02, 47/12

Other: WPI, Claims, Japio

Documents considered to be relevant:

Category	Identity of document and relevant passage	Relevant to claims
A	GB 2274513 A (WINTON) e.g. see Figure 1. Page 9 line 1 - page 12 line 17.	

X	Document indicating lack of novelty or inventive step	A	Document indicating technological background and/or state of the art.
Y	Document indicating lack of inventive step if combined with one or more other documents of same category.	P	Document published on or after the declared priority date but before the filing date of this invention.
&	Member of the same patent family	E	Patent document published on or after, but with priority date earlier than, the filing date of this application.